

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:)
)
 NISHIMOTO et al) Group Art Unit: 2814
)
 Serial No.: 08/897,839) Examiner: K. Eaton
)
 Filed: July 21, 1997) VIA FACSIMILE
) 703 308 7722
 For: STRESS-ADJUSTED INSULATING)
 FILM FORMING METHOD,)
 SEMICONDUCTOR DEVICE AND)
 METHOD OF MANUFACTURING THE)
 SAME)

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 2.136

Assistant Commissioner for Patents
 Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of February 3, 2000, initially set to expire May 3, 2000, be extended one month up to and including June 3, 2000. Please charge the requisite \$110.00 fee for the requested extension to our deposit account number 12-2174.

Any additional fees may also be charged to our Deposit Account No. 12-2174.

Respectfully submitted

George A. Loud
 Reg. No. 25,814

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